

FORM HDP-1449 (Based on Form PTO-1449)

PATENT AND TRADEMARK OFFICE
INFORMATION DISCLOSURE CITATION
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Sheet 1 of 1

OCT 07 2003

ATTORNEY DOCKET NO.	SERIAL NO.
45900-000611/US	09/867,606
APPLICANT	
Ib JOHANSEN et al.	
FILING DATE	GROUP
May 31, 2001	2643

U.S. PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Name	Class/ Subclass	(If appropriate) Filing Date

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FOREIGN PATENT DOCUMENTS

Ref. Desig.	Examiner's Initials	Document Number	Date	Country	Class/ Subclass	Translation Yes	Translation No

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

Ref. Desig.	Examiner's Initials	
	BL	Ning et al., "Fabrication of a silicon micromachined capacitive microphone using a dry-etch process" Sensors and Actuators A 53 (1996) 237-242

Examiner: *B. Enay*

Date Considered: 4/20/04

EXAMINER: Please initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.